Supplementary Information: Ultrafast Carrier Trapping in Thick-Shell Colloidal Quantum Dots

Ankit Jain,^{†,§} Oleksandr Voznyy,^{†,§} Marek Korkusinski,[†] Pawel Hawrylak,[‡] and

Edward H. Sargent*,¶

National Research Council of Canada, Canada, Department of Physics, University of Ottawa, Ottawa, K1N 6N5, Canada, and Department of Electrical and Computer Engineering, University of Toronto, 10 King's College Road, Toronto, Ontario, M5S 3G4, Canada

E-mail: ted.sargent@utoronto.ca

Spatial Location of Trap

Table S1: The variation of trapping lifetime for trapping through process (iii) for traps located at 60 meV above the VBM.

Trapping Lifetime (ns)	interface	outer surface
Config-1	3.8×10^{-5}	0.001
Config-2	$4.2 imes 10^{-5}$	0.001
Config-3	4.0×10^{-5}	0.001

*To whom correspondence should be addressed

[†]National Research Council of Canada, Canada

[‡]Department of Physics, University of Ottawa, Ottawa, K1N 6N5, Canada

[¶]Department of Electrical and Computer Engineering, University of Toronto, 10 King's College Road, Toronto, Ontario, M5S 3G4, Canada

[§]Contributed equally to this work

Participation Ratio

We calculate the participation ratio, PR, of a given state, *i*, as:

$$\mathbf{PR}_{i} = \frac{\left(\sum_{a} |e_{a}^{i}|^{2}\right)^{2}}{\sum_{a} |e_{a}^{i}|^{4}},$$
(S1)

where e^i is the eigenvector of electronic state *i* and summations are over all atoms, *a*. PR is equal to unity for a localized state and is equal to number of atoms for completely a delocalized state.